

RESPONSE UNDER 37 C.F.R. §1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP 1792

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

**Applicant(s):** Kwang Choe et al.

**Examiner:** Padgett, Marianne L.

**Serial No.:** 10/674,648

**Art Unit:** 1792

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**Title:** SOI BY OXIDATION OF  
POROUS SILICON

**Date:** March 16, 2009

**Confirmation No.:** 4794

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA. 22313

RESPONSE UNDER 37 C.F.R. § 1.116

Sir:

In response to the Final Office Action dated January 16, 2009, Applicants respectfully request that the following amendments and remarks be entered as a matter of record in the above-identified application. Also included herein is an Examiner Interview Summary of the phone interview between Examiner Marianne L. Padgett and Applicants' representative held on March 16, 2009.

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CERTIFICATE OF ELECTRONIC FILING

I hereby certify that this correspondence is being deposited with the United States Patent & Trademark Office via Electronic Filing through the United States Patent and Trademark Office e-business website, on March 16, 2009.

Dated: March 16, 2009

  
Harry A. Hild Jr